Fluorographenes via Thermal Exfoliation of Graphite Oxide in SF6, SF4 and MoF6 atmospheres

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Fluororaphenes via Thermal Exfoliation of Graphite Oxide in SF$_6$, SF$_4$ and MoF$_6$ atmospheres

Hwee Ling Poh$^a$, Zdeněk Sofer$^b$, Kateřina Klímová$^b$ and Martin Pumera$^a$*

Functionalization of graphene with heteroatoms is of paramount interest. Doping of graphene materials with electron withdrawing groups leads to the opening of the band gap which further results in a change of its electronic and electrochemical properties. Fluorine exhibits the largest electronegativity and thus it is expected that fluororaphenes will have significantly different properties from graphene. Fluorinated graphene was prepared by a scalable method using thermal treatments (at different temperatures) or microwave plasma exfoliation of graphite oxides (prepared via chlorate or permanganate routes) in atmospheres containing SF$_6$, SF$_4$ or MoF$_6$ fluorination agents. We characterized the resulting fluororaphenes by scanning electron microscopy, Raman spectroscopy, X-ray photoelectron spectroscopy, combustible elemental analysis and cyclic voltammetry. It was observed that with increasing fluorine content the heterogeneous electron transfer rates increases. The scalable fluorination of graphene with relatively low-toxic agents which yields high-performance electrochemical materials should find many applications in electrochemical devices, such as sensors or supercapacitors.

**Introduction**

Graphene, a single atomic layer of carbon atoms have fascinated many researchers with its numerous excellent advantages such as its mechanical, optical, electrical and electrochemical properties. However, intensive research works have been carried out where graphene were utilized in important future applications such as supercapacitors and biosensors. Despite many advantageous properties, certain characteristics of graphene such as zero band gap have proved the material to be a challenge for some applications. Therefore, intensive studies were carried out to dope/derivatize graphene with various elements in an attempt to improve the disadvantages that graphene has posed. Researches have previously showed that derivatization/doping of graphene is possible with elements such as halogens (Cl, Br, I),
itrogen, hydrogen, sulphur, boron,
halogen atoms offer simple and controllable functionalization of graphene, as they bond to carbon structure via uncomplicated single C-X bond; this is in contrary of several functional groups the other heteroatoms such as N, P, S or even B can create. Halogen doping offers way to tune the band gap via either choice of the halogen or via halogen coverage of graphene sheets. Among several of these materials, fluorinated graphene has been widely known to be one of the more stable doped graphene materials to be synthesized as compared to its other doped counterparts. This property is especially crucial in applications where stability of the materials is a major concern as the reliability and effectiveness of the device is directly affected by the quality of the material. The production of fluorinated graphene was often achieved with reagents such as xenon difluoride (XeF$_2$)\textsuperscript{14-17}, Ar/F$_2$\textsuperscript{19}, sulfur hexafluoride (SF$_6$)\textsuperscript{10}, fluoropolymers\textsuperscript{20} or tetrafluoromethane (CF$_4$)\textsuperscript{21,23}. Since XeF$_2$ and F$_2$ are highly toxic, expensive and/or corrosive, we have focused on the fabrication of fluorinated graphenes via synthesis using SF$_6$ and other less commonly used fluorine sources such as sulfur tetrafluoride (SF$_4$) and molybdenum hexafluoride (MoF$_6$). Additionally, we have focused on methodology which is able to be scalable, yielding grams or kilograms of the material. For this reason we used method based on thermal exfoliation of graphite oxide, which can be prepared in gram/kilogram quantities, in SF$_6$, SF$_4$ or MoF$_6$ atmospheres. This is in comparison with previous methods where only individual monolayers of graphene were functionalized with fluorine. Because it has been previously shown that composition of graphite oxide, that is, whether it is prepared by chlorate (Staudenmaier or Hofmann) or permanganate (Hummers) routes exhibits strong influence on the incorporation of sulphur and phosphorus, herein we will also study the influence of graphite oxide origin upon fluorine incorporation as well. We have characterized the products...
Results and Discussion

We have first prepared graphite (GO) oxides from graphite using various methods, chlorate (Staudenmaier (ST) or Hofmann (HO)) and permanganate (Hummers (HU)) based. Consequently, we exfoliated the graphite oxide in atmosphere of fluorination agent, such as SF₆, SF₄ and MoF₆ (Scheme 1). Resulting fluorinated materials were labelled in accordance to their methods of preparation, which includes the type of graphite oxide and fluorination agent source used and the temperature, e.g. HO-F: [SF₆/800°C]. In-depth characterization of the materials was performed using an array of different techniques to determine the properties of each material. A range of methods that were employed includes scanning electron microscopy (SEM), X-ray photoelectron spectroscopy (XPS), combustible elemental analysis, Raman spectroscopy and an electrochemical cyclic voltammetry technique. The results obtained were also further compared against standards such as non-fluorinated thermally reduced graphene oxides (TRGOs) synthesized from Hummers, Staudenmaier and Hofmann methods. The standard materials are labelled as HU, ST and HO for materials produced from Hummers, Staudenmaier and Hofmann methods respectively. Such a comparison allows a clearer understanding of how chemical treatments with fluorine sources influence the properties of graphene oxides.

We compare Hummers, Staudenmaier and Hofmann method of synthesis of graphite oxide due to the fact that there were previously shown to have strong effect on incorporation of heteroatom in the graphene.¹⁰ As such, we will investigate the properties of fluorinated graphene synthesized using three different fluorine sources: SF₆, SF₄ and MoF₆. SEM images of HU-F: [SF₆/800°C], HU-F: [SF₄/800°C] and HU-F: [MoF₆] are as shown in Figure 1 where the materials were observed at x50,000, x10,000, x6,000 and x370 magnifications. XPS results have shown that HU-F: [SF₆/800°C] have the highest fluorine content which will be further discussed later. As such, similar treatment methods have been employed for HO-F and ST-F (where HO-F stands for Hofmann method prepared graphite which was thermally exfoliated and fluorinated by one of the agents; ST-F stands for similar material originating from Staudenmaier method prepared GO) to observe if identical results were also observed for these materials. SEM images for these materials are as shown in Figure 1. Fluorination method was also performed in microwave plasma graphene oxide (MW-F: [SF₆]) and reaction temperature was also further varied for the same fluorine source (ST-F: [SF₆/1000°C]). The SEM images for these materials and the control materials (HU, HO and ST-GO exfoliated in the inert atmospheres) are also shown in Figure 1. It can be observed that all the fluorinated materials and their standards display images that are typical of fully exfoliated thermally reduced graphene oxides. This implies that all fluorinated graphenes are exfoliated during the synthesis process. One should note that SF₆ is completely safe gas, used in industry as insulator gas in high voltage insulation. SF₄ and MoF₆ are highly toxic; MoF₆ is low boiling point liquid (b.p, 36 °C) which is prone to hydrolysis by humidity.

Further surface properties such as the density of defects were also investigated through Raman spectroscopy. The amount of defects in a material is determined by the intensities of the D band and G band at 1350 cm⁻¹ and 1560 cm⁻¹ respectively. D band represents the presence of sp³ defects found in the pristine sp² lattice while G band is derived from the pristine sp² graphene network lattice. Therefore, calculation of the D/G ratio from the intensities of the two peaks provides insight on the density of defects present in each material. The Raman spectrum of the individual materials are as shown in Figure 2. In the comparison between Hummers materials, HU-F: [SF₆/800°C] showed a D/G ratio of 1.16, HU-F: [SF₆/800°C] has a D/G ratio of 1.17 followed by HU-F: [MoF₆] of 0.93.
HO-F: [SF₆/800°C] was observed to have a D/G ratio of 1.14 while MW-F: [SF₆] was found to have a density of defects of 0.95. Similarly, ST materials were treated with the same fluorine source at the same temperature to give ST-F: [SF₆/800°C]. ST-F: [SF₆/800°C] was observed to possess a D/G ratio of 0.86 while ST-F: [SF₆/1000°C] has a ratio of 0.59. The materials used as standards for comparison are HU, HO and ST which were found to possess ratios of 0.97, 1.09 and 0.77 respectively. The D/G ratios each material are presented as a bar graph for comparison as shown in Figure 2, D. It can be easily observed that materials doped using SF₆ as the source at 800°C usually possess the highest D/G ratio as compared to their counterpart materials. It was also found that all materials doped with SF₆ or SF₄ as the fluorine source have higher D/G ratios as compared to their respective standards with the exception of ST-F: [SF₆/1000°C]. For standard deviation of D/G ratios see Table S-1. This indicates that doping of the materials with fluorine leads to the introduction of defects onto the surface where earlier reports have shown similar findings of higher D/G ratios after fluorination. The average crystallite size of the materials can also be calculated using the peaks’ intensities and the following equation:

\[ L_a = 2.4 \times 10^{-10} \times \lambda_{\text{laser}}^4 \times \frac{I_G}{I_D} \]

where \( L_a \) is the average crystallite size of the material, \( I_G \) and \( I_D \) denotes the intensity of the G and D peaks respectively while \( \lambda_{\text{laser}} \) is the wavelength of the laser used in nm. The \( L_a \) calculated for the materials are 14.44 nm for HU-F: [SF₆/800°C], 14.35 nm HU-F: [SF₆/800°C] and 18.09 nm for HU-F: [MoF₆]. HO-F: [SF₆/800°C] has a value of 14.71 nm, MW-F: [SF₆] has a value of 17.71 nm. ST-F:
[SF$_6$/800°C] has a value of 19.59 nm while ST-F: [SF$_6$/1000°C] has a value of 28.50 nm. The standards have the following sizes of 17.30 nm, 15.41 nm and 21.70 nm for HU, HO and ST respectively. Similarly, materials doped using SF$_6$ at 800°C usually have the smallest crystallite size as compared to their counterparts.

In addition we measured micro-photoluminescence spectra using 325 nm a 532 nm laser excitation. The spectra for both excitation wavelengths are shown on Figure SI 1. No luminescence was observed for UV excitation up to 500 nm. Weak band around 341 nm and 360 nm originate from Raman scattering (D, G and 2D bands). For the UV excitation on samples HO-F:[SF$_6$/800°C] and HU-F:[SF$_6$/800°C] exhibit luminescence with maximum at 540 nm and 730 nm, respectively. For the green laser excitation (532 nm) we observed strong luminescence in NIR-IR region with maxima in the range of 970 – 1000 nm. This was observed for samples originated from HO and HU graphene except HU-F: [MoF$_6$] sample. This correspond to band-gap energy of 1.2 – 1.3 eV. The line observed at 685 nm on some samples originates from laser plasma line. In addition to photoluminescence the absorbance of F doped graphene suspension were measured. Absorbance spectra are shown on figure SI 2. The absorbance is constant in the range of 1100 – 300 nm with subsequent decrease for the wavelength below 300 nm. No correlation with photoluminescence measurement can be observed in comparison due to the high absorption coefficient and heterogeneous nature of graphene suspensions.

Surface elemental composition of the materials was determined using X-ray photoelectron spectroscopy (XPS). A wide-range scan was performed on the materials as shown in Figure 3, A, B and C. All materials showed C 1s peak at 284.5 eV, O 1s peak at 534 eV as the major peaks. F 1s peak at approximately 688 eV could be clearly observed for all fluorinated materials as denoted in Figure 3. The relative amount (%) of the total counts for F 1s for each material compared to carbon content was computed and shown in the bar graph as shown in Figure 3, D. Most commonly synthesized HU materials are fluorinated to give HU-F: [SF$_6$/800°C] with the highest F 1s composition of 1.92% followed by HU-F: [SF$_6$/800°C] with 0.53% HU-F: [MoF$_6$] with 0.26%. As such, similar treatment methods were applied to HO material to give HO-F: [SF$_6$/800°C] which possessed 0.59% of F 1s on the material’s surface. Microwave graphene was also fluorinated with SF$_6$ to give 1.05% of fluorine. ST-F: [SF$_6$/800°C] contains of 4.25% as the source at 800°C still provides the highest fluorine content regardless of the graphene (HU, HO, ST) starting material used.

The percentage content of each major element (nitrogen, carbon, hydrogen, fluorine and oxygen) can be obtained through CHN/O combustion elemental analysis. The result for each material is as summarized in Table 1. It can be observed that ST-F: [SF$_6$/800°C] has the highest atomic. % fluorine (at. % F) content of 2.40 followed by HU-F: [SF$_6$/800°C] of 2.21 %. HU-F: [MoF$_6$] was found to possess the lowest at. % F amount of just 0.84. This results show that fluorination using SF$_6$ as the source at 800°C still provides the highest fluorine content regardless of the material during fluorination. Hence, it was concluded that ST-F: [SF$_6$/800°C] has the highest percentage of fluorine on the surface of the material as compared to HU-F: [SF$_6$/800°C] and HU-F: [MoF$_6$]/800°C. This shows that fluorination using SF$_6$ as the source at 800°C still provides the highest fluorine content regardless of the graphite (HU, HO, ST) starting material used.
Figure 2. Raman spectra of fluorinated graphenes.

Figure 3. Wide-scan XP spectra of fluorinated graphenes.
The difference between HO, HU and ST graphite oxide is not only in C/O ratio, but also in the type of oxygen containing groups they contain. We have demonstrated this before.\textsuperscript{25} We have also showed that type of graphite oxide directly influence doping graphene with sulphur\textsuperscript{10} or hydrogenation of the material.\textsuperscript{26}

A high-resolution XPS (HR-XPS) scan was also performed for the specific electronic state of the element of interest. We have measured the HR-XPS for F 1s (Figure 4) and C 1s (Figure S3) to investigate the various bond interactions present for each element. All fluorinated materials displayed a single and symmetrical F 1s peak at approximately 688 eV binding energy as observed in Figure 4, A for fluorinated HO materials; Figure 4, B for fluorinated HU materials; and Figure 4, C for fluorinated ST materials. F 1s peak at similar binding energy was previously observed in other works.\textsuperscript{14}

In the HR-XPS spectra of the various materials (as shown in Figure S-3, A, B and C), further processing of the results obtained were performed to gain insights on the bond interactions of C 1s. Relative sensitivity factors were taken into considerations during careful fitting of the high-resolution XPS spectrum. Fitting of the XPS spectra was executed to investigate the different types of bonding interactions that existed for the electronic state of a specific element. The fitted results are as observed in Figure S-3, A for HO materials, B for HU materials and C for ST materials where spectra of fluorinated and non-fluorinated standards (HU, HO and ST) are included for comparison. The C 1s spectra of all standards consists of C=C at 284.5 eV, C-C at 285.7 eV, C-O at 286.7 eV, C=O at 288.0 eV, O-C=O at 289.0 eV and π*-π* at 290.5 eV. The percentages for each bond type of the individual materials are as tabulated in Table S-2 (Supporting Information). All fluorinated materials possess almost all the standard non-fluorinated C 1s bond types as

### Table 1. Composition of fluorinated graphenes based on combustible elemental analysis.

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<tr>
<th>Sample</th>
<th>At. % N</th>
<th>At. % C</th>
<th>At. % H</th>
<th>At. % F</th>
<th>At. % O</th>
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<td>HO-F: [SF\textsubscript{6}/800°C]</td>
<td>0.05</td>
<td>76.52</td>
<td>1.14</td>
<td>1.45</td>
<td>20.84</td>
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<tr>
<td>HU-F: [SF\textsubscript{6}/800°C]</td>
<td>0.05</td>
<td>77.40</td>
<td>4.50</td>
<td>2.04</td>
<td>16.00</td>
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<td>HU-F: [SF\textsubscript{6}/800°C]</td>
<td>0.02</td>
<td>75.88</td>
<td>1.64</td>
<td>1.80</td>
<td>20.66</td>
</tr>
<tr>
<td>ST-F: [SF\textsubscript{6}/1000°C]</td>
<td>0.02</td>
<td>91.84</td>
<td>0.24</td>
<td>0.92</td>
<td>6.98</td>
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<tr>
<td>ST-F: [SF\textsubscript{6}/800°C]</td>
<td>0.57</td>
<td>80.33</td>
<td>1.86</td>
<td>2.40</td>
<td>13.84</td>
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<tr>
<td>HU-F: [MoF\textsubscript{6}]</td>
<td>0.00</td>
<td>74.87</td>
<td>6.57</td>
<td>0.84</td>
<td>17.72</td>
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<tr>
<td>MW-F: [SF\textsubscript{6}]</td>
<td>0.06</td>
<td>85.49</td>
<td>2.90</td>
<td>1.47</td>
<td>10.09</td>
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**Figure 4.** High-resolution XPS of fluorinated graphenes at energy of F 1s.
reported in literature where studies were performed on graphene materials after fluorination treatments.\textsuperscript{14-23} As observed in Table S-2, it can be concluded that the amount of C=C interactions decrease after fluorine treatments which indicates that fluorination depletes \( sp^2 \) C=C bonds.

Electrochemistry can provide further insight into two main characteristics of resulting materials. First, it is possible to evaluate presence of peroxy, aldehyde and epoxy groups by using cyclic voltammetry; second, it is possible to determine heterogeneous electron transfer rates of the resulting materials, which is crucial for their applications in electrochemical devices. To the point (i), the presence of oxygen containing groups on the surface of the materials can also be explored through the execution of CV in deoxygenated phosphate buffer solution (PBS). It was previously known that aldehyde, peroxy and epoxy groups in graphene oxide undergo chemically irreversible reduction.\textsuperscript{27} Cyclic voltammograms of the materials are as shown in Figure 5 where the results are obtained under room temperature conditions with a pH7.4 deoxygenated PBS. The CV results show that HU-F: [SF\textsubscript{6}/800°C], HU-F: [SF\textsubscript{6}/800°C], HU-F: [MoF\textsubscript{6}] and HU display no reduction peaks between 0 V and -1.6 V (refer to Figure 5, B). This results support the earlier observation in XPS where all materials have extremely high C/O ratios, indicating the presence of low amounts of oxygen containing groups. The materials of interest were also compared against another standard, unmodified bare glassy carbon (GC) electrode. Bare GC also expectedly exhibited no reduction peaks in deoxygenated PBS. HO materials were also examined using CV technique as shown in Figure 5, A where HO-F: [SF\textsubscript{6}/800°C], HO and bare GC show no visible reduction peaks. Similarly, fluorinated microwave graphene did not display a reduction peak from 0 V to -1.6 V during the CV scan. This result was expected as earlier XPS findings have shown that all HU materials have almost similar C/O ratios as the HO materials. All fluorinated and non-fluorinated ST materials (refer to Figure 5, C) has also shown no reduction peaks at all during CV scans. This was anticipated as all ST materials have the highest C/O ratios as compared to HU and HO materials hence, the least amount of oxygen functionalities on the surface.

The heterogeneous electron transfer (HET) rate of the materials were also investigated with CV methods in ferrocyanide solution ([Fe(CN)\textsubscript{6}]\textsuperscript{3-}) where the peak-to-peak separation (\( \Delta E_{p-p} \)) of each material can be examined (Figure 6). The calculated \( \Delta E_{p-p} \) values are 147 mV for HU-F: [SF\textsubscript{6}/800°C], 127 mV for HU-F: [SF\textsubscript{6}/800°C], 151 mV for HU-F: [MoF\textsubscript{6}] and 149 mV for HU. Bare GC has the largest peak-to-peak separation of 300 mV and hence, the slowest HET rate at the surface of the material. HO-F: [SF\textsubscript{6}/800°C], HO and fluorinated microwave graphene have \( \Delta E_{p-p} \) values of 117 mV, 142 mV and 125 mV respectively. Similar calculations were also performed for ST materials where ST-F: [SF\textsubscript{6}/800°C] has a value of 154 mV, ST-F: [SF\textsubscript{6}/1000°C] has a value of 188 mV and ST has a value of 156 mV. It was observed that bare GC has the widest peak separation among all the materials that were compared. It can also

- **Figure 5.** Inherent electrochemistry of fluorinated graphenes. Conditions: phosphate buffer, 50 mM, pH 7.2; scan rate 100 mV/s. mentioned above with the absence of a few bond interactions (refer to Table S-2). However, the appearance of some C-F bonds was observed for all the fluorinated materials such as C-CF at 286 eV, C\textsubscript{HOF} at 288.0 eV, C-F at 288.5 eV, C-F\textsubscript{2} at 291 eV where the various percentages of abundance are calculated and presented in Table S-2. The presence of such C-F interactions was also previously
be concluded that most GOs fluorinated with SF₆ at 800°C have the smallest peak-to-peak separation as compared to their fluorinated counterparts. The HET rates ($k_{\text{obs}}^0$) were then calculated using the Nicholson approach where $\Delta E_{p-p}$ is related to a dimensionless parameter $\phi$ which is eventually related to $k_{\text{obs}}^0$. The calculated $k_{\text{obs}}^0$ values are $2.27 \times 10^{-3}$ cm s$^{-1}$ for HU-F: [SF₆/800°C] and HO were found to possess $3.39 \times 10^{-3}$ cm s$^{-1}$ and $2.43 \times 10^{-3}$ cm s$^{-1}$ respectively. Fluorinated microwave graphene has a value of $3.07 \times 10^{-3}$ cm s$^{-1}$. ST-F: [SF₆/800°C] has a value of $2.06 \times 10^{-3}$ cm s$^{-1}$ while ST-F: [SF₆/1000°C] has a value of $1.29 \times 10^{-3}$ cm s$^{-1}$. The standard unfluorinated ST material has a HET value of $1.99 \times 10^{-3}$ cm s$^{-1}$ while bare GC has a value of $2.82 \times 10^{-4}$ cm s$^{-1}$. As expected, bare GC has the slowest electron transfer rate at the surface as compared to all the materials studied. Among the fluorinated materials, fluorinated microwave graphene has the fastest HET rate followed by materials that are fluorinated with SF₆ at 800°C. There is general trend where electrochemical performance increases with increased fluorination within the type of graphite oxide precursor. The observed deviations may be hypothesized to be caused by different topology of fluorination - fluoronated graphene lead into the creation of islands in the graphene lattice, as shown recently.

**Conclusion**

We have successfully demonstrated the fluorination of graphene using reagents such as SF₆, SF₅ and MoF₆. The materials obtained are then extensively studied through various characterization techniques such as XPS, Raman spectroscopy, electrochemistry and combustible elemental analysis to investigate their properties. The use of SF₆ as fluorination agent at 800°C have produced the highest fluorine content as compared to other fluorine sources. The presence of fluorine content as high as 4.25% has also resulted in interesting properties such as fast electron transfer rates at the material’s surface which has important implications for future electrochemical applications.

**Experimental Section**

**Materials**

Sulphuric acid (98 %), nitric acid (fuming, 98 %), nitric acid (68%), potassium chloride (98 %), hydrochloric acid (37 %), sodium nitrate (99.5%), potassium permanganate (99%), hydrogen peroxide (30%), silver nitrate (99.5 %) and barium nitrate (99.5 %) were obtained from PENTA, Czech Republic. Graphite microparticles (2-15 µm) were obtained from Sigma-Aldrich, Singapore. Deionized water was used for the preparation of the electrolytes that were used in all the electrochemical measurements. Glassy carbon working electrode (GC), platinum auxiliary electrode (Pt) and Ag/AgCl reference electrode were purchased from Autolab, The Netherlands.

**Apparatus**

![Figure 6. Heterogeneous electron transfer at fluorinated graphenes. Conditions: phosphate buffer, 50 mM, pH 7.2; scan rate 100 mV/s; 10 mM ferro/ferricyanide as depolarizer.](image-url)
JEOL 7600F field-emission scanning electron microscope, Japan was used to obtain SEM images. The samples were affixed onto the sample stub with a conductive carbon tape. The XPS and HR-XPS measurements were acquired with a Phoibos 100 spectrometer and a monochromatic Mg X-ray radiation source (SPECS, Germany). All measurements were executed with a 12.53 kV X-ray source. A XPS sample holder and a sticky conductive carbon tape was used to attach the XPS samples. A homogeneous and uniform layer of the material was attached onto the tape before the sample was loaded into the XPS chamber for a measurement. Confocal micro-Raman LabRam HR instrument (Horiba Scientific) in backscattering geometry with a CCD detector was used for Raman spectroscopic measurements. Silicon wafer was utilized for calibration at 0 cm\(^{-1}\) and 520 cm\(^{-1}\) to give a peak position resolution of less than 1 cm\(^{-1}\). A 514.5 nm Ar laser, an Olympus optical microscope and a 100x objective lens was used for all the measurements. All materials were well-compressed and compacted prior to any measurement. Combustible elemental analysis (CHNS-O) was performed with a PE 2400 Series II CHNS/O Analyzer (Perkin Elmer, USA). In CHN operating mode (the most robust and interference free mode), the instrument employs a classical combustion principle to convert the sample elements to simple gases (CO\(_2\), H\(_2\)O and N\(_2\)). The PE 2400 analyzer performs automatically combustion and reduction, homogenization of product gases, separation and detection. A microbalance MX5 (Mettler Toledo) is used for precise weighing of samples (typically 1.5 – 2.5 mg per single sample analysis). The accuracy of CHN determination is better than 0.30% abs. Internal calibration is performed using N-phenyl urea. Electrochemical voltammetric measurements were performed using a microAutolab Type III electrochemical analyzer (Eco Chemie, The Netherlands) and a NOVA 1.7 software (Eco Chemie). Nova 1.7 software was published by Metrohm Autolab B.V. in support of Metrohm Autolab’s potentiostat/galvanostat equipment. The microphotoluminescence spectra were measured using Renishaw In-Via confocal Raman microscope. For the measurement were used He-Cd laser (325 nm, 22 mW) and DPSS laser (532 nm, 50 mW). The measurement was performed with a 40x UV objective and 50x VIS-NIR objective. Silicon wafer was utilized for calibration at 0 cm\(^{-1}\) and 520 cm\(^{-1}\) Raman shift for both lasers to give a peak position resolution of less than 1 cm\(^{-1}\). The UV-VIS absorbance spectra were measured in 200 - 1100 nm range using Cary 50 spectrometer (Agilent, USA). For the measurement the suspension in hexane were prepared by ultrasonication (400 W, 10 minutes, 1 mg/mL).

### Synthesis procedure of Hofmann graphite oxide

Graphite oxide preparation with the Hoffman method: 87.5 mL of sulfuric acid (98 %) was cooled to 0 °C and then 5 g of graphite and 2.5 g of NaNO\(_3\) were added to the mixture. While vigorously stirred, 15 g of KMnO\(_4\) were added over a period of two hours. The reaction mixture was then removed from the cooling bath and stirred at room temperature for 4 hours. The reaction mixture was then heated to 35 °C for 30 minutes, poured into 250 ml of deionized water and heated to 70 °C. After 15 minutes the mixture was poured into 1 L of deionized water. Unreacted KMnO\(_4\) was decomposed with 10% hydrogen peroxide. The reaction mixture was then decanted and repeatedly centrifuged and re-dispersed until a negative reaction for sulfate ions ([Ba(NO\(_3\))]\(_2\)) was achieved. Graphite oxide slurry was then dried in a vacuum oven at 60 °C for 48 hours before further use.

### Synthesis procedure of Hummers graphite oxide

Graphite oxide preparation with the Hummers method: 115 ml of sulfuric acid (98 %) was cooled to 0 °C and then 5 g of graphite and 2.5 g of NaNO\(_3\) were added to the mixture. While vigorously stirred, 15 g of KMnO\(_4\) were added over a period of two hours. The reaction mixture was then decanted and repeatedly centrifuged and re-dispersed until a negative reaction for sulfate ions ([Ba(NO\(_3\))]\(_2\)) was achieved. Graphite oxide slurry was then dried in a vacuum oven at 60 °C for 48 hours before further use.

### Synthesis procedure of Staudenmaier graphite oxide

Graphite oxide preparation with the Staudenmaier method: 87.5 ml of sulfuric acid (98 %) and 27 ml of nitric acid (98 %) were first cooled to 0 °C before 5 g of graphite were added to the mixture. The reaction mixture was then continuously stirred for 72 h at room temperature. Upon completion of the reaction, the mixture was poured into 3 L of deionized water and decanted. Graphite oxide was then redispersed in HCl (5 %) solutions to remove sulphate ions and repeatedly centrifuged and redispersed in deionized water until a negative reaction on chloride and sulphate ions (with AgNO\(_3\) and Ba(NO\(_3\))\(_2\) respectively) was achieved. Graphite oxide slurry was then dried in a vacuum oven at 50 °C for 48 h before use.

### Photoluminescence measurement

Excitation of the FL-AF sample was performed with He-Cd laser (325 nm, 22 mW) and DPSS laser (532 nm, 50 mW). The PL spectra were measured using Renishaw In-Via confocal Raman microscope. For the measurement were used He-Cd laser (325 nm, 22 mW) and DPSS laser (532 nm, 50 mW). The UV-VIS absorbance spectra were measured in 200 - 1100 nm range using Cary 50 spectrometer (Agilent, USA). For the measurement the suspension in hexane were prepared by ultrasonication (400 W, 10 minutes, 1 mg/mL).

### Electrochemical measurements

Voltammetric measurements were performed using Autolab's potentiostat/galvanostat equipment. The micro-photoluminescence spectra were measured using Renishaw In-Via confocal Raman microscope. For the measurement were used He-Cd laser (325 nm, 22 mW) and DPSS laser (532 nm, 50 mW). The measurement was performed with a 40x UV objective and 50x VIS-NIR objective. Silicon wafer was utilized for calibration at 0 cm\(^{-1}\) and 520 cm\(^{-1}\) Raman shift for both lasers to give a peak position resolution of less than 1 cm\(^{-1}\). The UV-VIS absorbance spectra were measured in 200 - 1100 nm range using Cary 50 spectrometer (Agilent, USA). For the measurement the suspension in hexane were prepared by ultrasonication (400 W, 10 minutes, 1 mg/mL).

### Photoluminescence measurement

Excitation of the FL-AF sample was performed with He-Cd laser (325 nm, 22 mW) and DPSS laser (532 nm, 50 mW). The PL spectra were measured using Renishaw In-Via confocal Raman microscope. For the measurement were used He-Cd laser (325 nm, 22 mW) and DPSS laser (532 nm, 50 mW). The UV-VIS absorbance spectra were measured in 200 - 1100 nm range using Cary 50 spectrometer (Agilent, USA). For the measurement the suspension in hexane were prepared by ultrasonication (400 W, 10 minutes, 1 mg/mL).
precursor was used in the case of SF₆ and SF₆. The mixture of nitrogen and fluorine precursor was used for the fluorination process with MoF₆. First, the fluorine precursor flow (0.5 L/min) was stabilized for 5 minutes. For the fluorination with MoF₆, we used the mixture of MoF₆ gas (0.3 L/min) and nitrogen (1 L/min). The temperature of exfoliation was 800 °C and 1000 °C respectively. Then the capsule with the sample was inserted into the furnace for 12 minutes and pulled out again at the end of the reaction. The 12 minutes exposure of graphene at these conditions led to a complete exfoliation and fluorination. All exfoliation steps were performed under atmospheric pressure.

Synthesis procedure of fluorine doped graphene–microwave plasma exfoliation:

Synthesis of fluorinated graphene in microwave SF₆ plasma: The synthesis of fluorine doped graphene was performed in low pressure fluorine microwave plasma generated from SF₆. The graphite oxide prepared according to Hofmann method was placed inside a quartz glass reactor which was evacuated and flushed with nitrogen. At the base pressure of 1 mbar, the SF₆ gas was introduced inside quartz glass reactor (0.1 L/min, 5 mbar) and the graphite oxide was exfoliated by applying microwave radiation for 30 s (1 kW, 2.45 GHz). The exfoliation procedure was accompanied by the increase of the pressure to about 20 mbar. The reactor was again evacuated and flushed with the sulfur hexafluoride gas (0.1 L/min) to remove the exfoliation byproducts and at the pressure of 5 mbar and continual flow of SF₆ the microwave radiation was applied for 3 minutes. Application of microwave radiation on SF₆ at reduced pressure led to the formation of fluorine plasma.

Cyclic Voltammetry

The glassy carbon electrodes were cleaned by polishing with alumina suspension to renew the electrode surface then washed and wiped dry prior to use. The materials were dispersed in DMF as the solvent to obtain a 1.0 mg·mL⁻¹ suspension. The suspension was then sonicated for 5 minutes at room temperatures before each use. A cleaned GC electrode was then modified by coating with a 1 µL aliquot of the suspension and left to dry under a lamp to give a layer of randomly dispersed material. The modified GC electrodes, Ag/AgCl reference electrode, and Pt counter electrode were then placed into an electrochemical cell which contains the electrolyte. The electrolytes used were 50 mM pH7.4 deoxygenated phosphate buffer solution (PBS) and 10 mM Ferro/Ferricyanide dissolved in PBS. All measurements were performed for two consecutive scans at a scan rate of 100 mV s⁻¹ where three measurements were carried out for each material and also for each electrolyte. The deoxygenation of the 50 mM pH7.4 PBS was achieved by bubbling nitrogen gas into the PBS for 15 minutes before each use.

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Notes and references

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13 D. Sen, K. S. Novoselov, P. M. Reis, & M. J. Buehler, Small, 2011, 6, 1108.
Graphite Oxide
(Staudenmaier, Hofmann, Hummers)

$T=800-1000^\circ\text{C}$
or Microwave

Fluorographene

63x39mm (300 x 300 DPI)